



2143

Docket No. 3553-4075US3

42

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Scott Nedderman et al. Group Art Unit: TBA
Serial No : 09/707,211 Examiner: TBA
Filed : November 3, 2000
For : APPARATUS, SYSTEM AND METHOD FOR MAINTAINING
A PERSISTENT DATA STATE ON A COMMUNICATIONS
NETWORK

Commissioner for Patents
P.O. BOX 1450
Alexandria, VA 22313

REQUEST TO CHANGE CORRESPONDENCE ADDRESS

Sir.:

Please change the correspondence address of record in the above-identified application
and direct all future correspondence to:

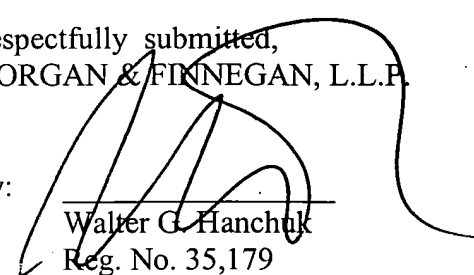
**Walter G. Hanchuk
MORGAN & FINNEGAN, L.L.P.
345 Park Avenue
New York, New York 10154
Telephone No.: (212) 758-4800
Facsimile No.: (212) 751-6849**

Dated: May 16, 2003

MORGAN & FINNEGAN, L.L.P.
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Respectfully submitted,
MORGAN & FINNEGAN, L.L.P.

By:


Walter G. Hanchuk
Reg. No. 35,179

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CERTIFICATE OF MAILING

Commissioner For Patents
P.O. BOX 1450
Alexandria, VA 22313

Sir:

I hereby certify that the attached

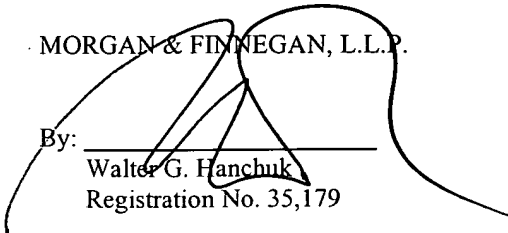
- (1) Request to Change Correspondence Address
- (2) Return postcard.

along with any paper(s) referred to as being attached or enclosed and this Certificate of Mailing are being deposited with the United States Postal Service on the date shown below with sufficient postage as first-class mail in an envelope addressed to the: Commissioner of Patents, Washington, D.C. 20231.

Respectfully submitted,

MORGAN & FINNEGAN, L.L.P.

Date: May 21, 2003

By: 
Walter G. Hanchuk
Registration No. 35,179

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